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PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/611,037  
Applicant: : Kuthi, et al.  
Filed: : July 6, 2000  
Title: : METHOD FOR IMPLEMENTING A  
SEMICONDUCTOR PROCESS CHAMBER  
ELECTRODE

TC/A.U. : 1763  
Examiner : Alejandro Mulero, L.

Atty. Docket No. : LAM1P077A  
Date: : February 5, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## CERTIFICATE OF FACSIMILE

I hereby certify that this paper and the documents referred to as attached thereto are being transmitted by facsimile on February 5, 2004 to the United States Patent & Trademark Office, Attention Luz ALEJANDRO, Technology Center 1700, Alexandria, VA 22313-1450, to facsimile number (703) 872-9306.

Signed:

Neely Jo. Entuella

## AMENDMENT

Sir:

Applicants submit this paper in response to the Office Action dated November 5, 2003. The period for response extends to February 5, 2004. Please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Argument begins on page 8 of this paper.